

Electronic Patent Application Fee Transmittal

Application Number:	10019407			
Filing Date:	25-Mar-2002			
Title of Invention:	POLYSILICON SEMICONDUCTOR THIN FILM SUBSTRATE, METHOD FOR PRODUCING THE SAME, SEMICONDUCTOR DEVICE, AND ELECTRONIC DEVICE			
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Filer:	Larry Naoum Anagnos/Donald Prater			
Attorney Docket Number:	520.41003 X00			
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Printed copy of patent - no color	8001	4	3	12
Total in USD (\$)				1522